[TS04T3]

Nano/MEMS Processing & Packaging for Intelligent & Quantum Applications 3

Date & Time	July 9(Thu.), 2026 / 09:30-11:00
Place	Room 206B
Session Chair(s)	Prof. Hanul Moon (Dong-A University)

TS04T3_I_1 ***Invited** 09:30-10:00

Compact Metasurface Systems for 3D Imaging and Sensing

Hao Wang
(Beihang University)

TS04T3_I_2 ***Invited** 10:00-10:30

Aluminum 3D Lithography: Enabling High-Dimensional Metasurface for Advanced Sensing

Liaoyong Wen
(Westlake University)

TS04T3_I_3 ***Invited** 10:30-11:00

Quantum Dots as Artificial Building Blocks: Hybrid Nanofabrication Across Multiple Length Scales

Tae Won Nam
(Pusan National University)